Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination		
10/766,465	MA ET AL.	•	
Examiner	Art Unit		
Su C. Kim	2823		

	SEARCHED				
Class	Subclass	Date	Examiner		
257	288	11/23/2007	SK		
257	401	11/23/2007	SK		
257	910	11/23/2007	SK		
257	213	11/23/2007	SK		
257	214	11/23/2007	SK		
257	E29.148	11/23/2007	SK		
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438	292	11/23/2007	SK		
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438	295	11/23/2007	SK		
438	296	11/23/2007	SK		
438	297	11/23/2007	sk		
438	298	11/23/2007	sk		

INT	INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner		
Interference search		11/23/2007	SK		

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
Interference search (See search history printout)	11/23/2007	SK